



1725

Docket No.:0756-2393

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Ritsuko KAWASAKI, et al)
Serial No. 09/988,389) Group Art Unit: 1725
Filed: November 19, 2001) Examiner: Unassigned
For: LASER IRRADIATION METHOD AND)
METHOD OF MANUFACTURING A)
SEMICONDUCTOR DEVICE)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
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P. O. Box 1450, Alexandria VA 22313-1450, on November 18, 2003

Henry A. Davis

SECOND REQUEST FOR STATUS

Honorable Commissioner of Patents
P. O. Box 1450
Alexandria VA 22313-1450
Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

Eric J. Robinson
Reg. No. 38,285

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